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NORME INTERNATIONALE



Reflectivity of electromagnetic wave absorbers in millimetre wave frequency – Measurement methods (standards.iteh.ai)

Réflectivité des absorbeurs d'ondes électromagnétiques dans la plage des fréquences des ondes millimétriques – Méthodes de mesure

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INTERNATIONAL ELECTROTECHNICAL COMMISSION

COMMISSION ELECTROTECHNIQUE INTERNATIONALE



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CONTENTS

FO	FOREWORD		
1	Scope		
2	Normative references		
3	3 Terms definitions and acronyms		
	3.1 Terms and definitions	7	
	3.2 Acronyms and symbols	10	
4	Specimen	10	
	4.1 Specimen specification	12	
	4.1 Specification	۲۲ 12	
	4.2 Reference metal plate	12	
	4.2.1 Material and theorems	12	
	4.2.2 Surface roughness	12	
	4.2.4 Size and shane	12	
	4.3 Reference specimen for calibration	12	
5	Specimen holder	13	
6	Moasurement equipment	12	
0		13	
	6.1 Type of network analyzer	13	
	6.2 Antenna	13	
	6.2.1 Horn antenna. (standards.iteh.ai)	13	
	6.2 Amplifier	10	
	6.5 Ampliner	د ا 14	
7	0.4 Cable	۲4	
1	7306a9b32af/iec-62431-2008	14	
	7.1 Temperature and environment	14	
	7.2 Warming up of measurement equipment	14	
0	7.3 Electromagnetic environment	14	
0		14	
	8.1 Calibration of measurement system	14	
	8.2 Measurement conditions	14	
	8.2.1 Dynamic range	14	
	8.2.2 Setting up of the network analyzer for keeping adequate dynamic range	14	
9	Horn antenna method	15	
Ũ	9.1 Measurement system	15	
	9.1.1 Configuration of the measurement system	15	
	9.1.2 Horn antenna	15	
	9.1.2 Norn anternational of the second	10	
	9.1.4 Mounting of the specimen	18	
	9.1.5 Antenna stand	18	
	9.2 Measurement conditions.	18	
	9.2.1 Measurement environment		
	9.2.2 Measuring distance	18	
	9.2.3 Size of specimen		
	9.3 Measurement procedures	19	
10	Dielectric lens antenna method – focused beam method	20	
	10.1 Outline	20	

	10.2	Measurement system	20
		10.2.1 Transmitting and receiving antennas	20
		10.2.2 Focused beam horn antenna	21
		10.2.3 Specimen size	22
		10.2.4 Reference metal plate size	22
		10.2.5 Specimen noider	22
	10.3	Measurement procedures	23 23
11	Diele	ctric lens antenna method – parallel beam method	25
•••	11 1	Principle	25
		11.1.1. Outline	25
		11.1.2 Parallel EM wave beam formed using a EM wave lens	25
	11.2	Measurement system	26
		11.2.1 Composition of measurement system	26
		11.2.2 Dielectric lens antenna	29
	11.3	Specimen	29
		11.3.1 General	29
		11.3.2 Reference metal plate	29
		11.3.3 Size of specimen	30
	11.4	Measurement procedures	30
		11.4.1 Normal incidence AINLIAKLI P.K.E.V.I.E.VV	30
40	T 4	11.4.2 Oblique Incidence (Standards.iteh.ai)	30
12	rest		31
Anr	hex A	(informative) Reflection and scattering from metal plate – Horn antenna	33
Anr	nex B	(informative) Reflectivity of reference speet mensel using horn antenna method	38
Anr	nex C	(informative) Specifications of commercially available antennas	39
Anr	nex D	(normative) Calibration using VNA	42
Anr	nex E	(informative) Dynamic range and measurement errors	50
Anr	nex F	(informative) Enlargement of dynamic range – Calibration by isolation	52
Anr	nex G	(informative) Relative permittivity of styrofoam and foamed polyethylene	50
bas	ed on	Toam ratio	53
Anr	iex H	(Informative) Calculation of Fraunhofer region – Horn antenna method	54
Fig	ure 1	- Definition of reflectivity	10
Fia	ure 2	- Configuration of the measurement system normal incidence (S11)	15
Fig	ure 3	- Configuration of the measurement system oblique incidence (S_{24})	16
Fig	ure 4	- Mounting method of specimen	17
Fig	ure 5	- The mechanism of adjusting azimuth and elevation	17
Eig		Measurement evotem for normal incidence (side view)	20
Fig		Measurement system for obligue insidence (side view)	20
Fig			21
⊢ig –	ure 8	- Structure of a dielectric lens antenna	22
Figure 9 – Structure of specimen holder			
Fig	ure 10	D – EM wave propagation using a horn antenna and a dielectric lens	26
Fig	ure 11	– Block diagram of the measurement system	27
Fig	ure 12	2 – A measurement system for normal incidence	28

Figure 13 – Measurement system for oblique incidence	28
Figure 14 – Position of a shielding plate	29
Figure 15 – Items to be mentioned in a test report	32
Figure A.1 – Reflection from the reference metal plate versus measurement distance between the antenna and the metal plate	33
Figure A.2 – Reflectivity of reference metal plate versus size	34
Figure A.3 – Reflectivity of reference metal plate at 40 GHz	35
Figure A.4 – Reflectivity of reference metal plate with cross section of 200 mm × 200 mm at 40 GHz	35
Figure A.5 – Analysis of reflection from a metal plate	37
Figure B.1 – Reflectivity of a 200 mm \times 200 mm silica-glass plate in millimetre wave frequency	38
Figure C.1 – Representative specifications of a horn antenna	39
Figure C.2 – Structure of cylindrical horn antenna with dielectric lens in Table C.2, A used at 50 GHz - 75 GHz.	40
Figure C.3 – A structure of dielectric lens and horn antenna in Table C.2, D	41
Figure D.1 – Measurement configuration for the case of normal incidence with a directional coupler connected directly to the horn antenna	42
Figure D.2 – Configuration for response calibration using a reference metal plate in the case of normal incidence and structure and the case of normal incidence and structure and struc	43
Figure D.3 – Configuration for response calibration using a reference metal plate in the case of oblique incidence	44
Figure D.4 – Configuration for response and isolation calibration in the case of normal incidence <u>IEC.62431:2008</u>	45
Figure D.5 – Configuration for response and isolation calibration in the case of oblique incidence	45
Figure D.6 – Configuration for S_{11} 1-port full calibration in the case of normal incidence	46
Figure D.7 – Precision antenna positioner configuration	47
Figure D.8 – TRL calibration procedure	48
Figure D.9 – Measurement and TRL calibration of transmission line	49
Figure E.1 – An example of receiving level of a reference metal plate and that without a specimen	50
Figure E.2 – Dynamic range and measurement error of reflectivity	51
Figure F.1 – A method to remove spurious waves	52
Figure H.1 – Fraunhofer region and antenna gain	54

Table 1 – Acronyms	11
Table 2 – Symbols	11
Table C.1 – Antenna gain 24 dB (example A)	
Table C.2 – Some specifications of antennas with dielectric lenses	40
Table G.1 – Relative permittivity and foam ratio of styrofoam	53
Table G.2 – Relative permittivity and foam ratio of foamed polyethylene	53

INTERNATIONAL ELECTROTECHNICAL COMMISSION

REFLECTIVITY OF ELECTROMAGNETIC WAVE ABSORBERS IN MILLIMETRE WAVE FREQUENCY – MEASUREMENT METHODS

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International Standard IEC 62431 has been prepared by subcommittee SC46F: RF and microwave passive components, of IEC technical committee 46: Cables, wires, waveguides, R.F. connectors, R.F. and microwave passive components and accessories.

IEC 62431 replaces and cancels IEC/PAS 62431 with corrections of obvious errors as noted in 46F/29A/RVN.

This bilingual version published in 2011-11, corresponds to the English version published in 2008-07.

The text of this standard is based on the following documents:

CDV	Report on voting
46F/65/CDV	46F/72/RVC

Full information on the voting for the approval of this standard can be found in the report on voting indicated in the above table.

This publication has been drafted in accordance with the ISO/IEC Directives, Part 2.

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REFLECTIVITY OF ELECTROMAGNETIC WAVE ABSORBERS IN MILLIMETRE WAVE FREQUENCY – MEASUREMENT METHODS

1 Scope

This International Standard specifies the measurement methods for the reflectivity of electromagnetic wave absorbers (EMA) for the normal incident, oblique incident and each polarized wave in the millimetre-wave range. In addition, these methods are also equally effective for the reflectivity measurement of other materials:

- measurement frequency range: 30 GHz to 300 GHz;
- reflectivity: 0 dB to -50 dB;
- incident angle: 0° to 80°.

NOTE This standard is applicable not only to those EMA which are widely used as counter-measures against communication faults, radio interference etc., but also to those used in an anechoic chamber in some cases. EMAs may be any kind of material, and may have any arbitrary shape, configuration, or layered structure as pointed out below.

Material: Conductive material, dielectric material, magnetic material.

Shape: planar-, pyramidal-, wedge-type, or other specific shapes. PREVIEW

2 Normative references

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The following referenced documents are indispensable for the application of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

ISO/IEC 17025, General requirements for the competence of testing and calibration laboratories

3 Terms, definitions and acronyms

For the purposes of this document, the following terms and definitions apply.

3.1 Terms and definitions

3.1.1

ambient level

the value of radiation power or noise which exists when no measurement is being carried out at the experiment site

3.1.2

associated equipment

an apparatus or product connected for convenience or operation of the equipment

3.1.3

beam diameter

the diameter where the electric field strength decreases by 3 dB from the centre of the focused beam

3.1.4

beam waist

the portion at which the diameter of the focused beam becomes minimum when the electromagnetic waves radiated from a transmit antenna are converged using a dielectric lens

3.1.5

beam waist diameter

beam diameter at the beam waist

3.1.6

bistatic measurement

measurement where the incident and reflection angle are equal

3.1.7

dielectric lens

electromagnetic wave lens that is composed of dielectric material

Usually, it is used by mounting in front of a pyramidal or conical horn.

3.1.8

3.1.9

directional gain

ratio of the radiated power density in a particular direction to the average power density that would be radiated in all directions

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dynamic range

difference in decibels between the receiving level from the reference metal plate and the receiving level measured when the metal plate is removed

IEC 62431:2008

3.1.10 https://standards.iteh.ai/catalog/standards/sist/0b07e76f-406a-45c5-bbba-

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material ingredient which absorbs the electromagnetic wave energy and dissipates it thermally

3.1.11

focal distance

distance between the centre of the dielectric lens and the focal point

3.1.12

focal point

centre of the beam waist when the electromagnetic waves are converged using a dielectric lens

3.1.13

focused beam

focused electromagnetic wave converged by the dielectric lens mounted in front of the horn antenna

The focused beam diameter is a few times the wavelength or more at the beam waist, which depends on the focal distance of the lens.

3.1.14

fraunhofer region

region where the angular radiation pattern of an aperture antenna is nearly independent of the distance

3.1.15

free-space method

measurement method that employs a single or pair of horn antennas where the specimen and the antennas are put in free space

3.1.16

fresnel region

region where the angular radiation pattern of an aperture antenna depends on the distance except for the region extremely near to the aperture

3.1.17

horn antenna

aperture antenna where impedance matching is taken gradually from the waveguide aperture to free space

3.1.18

monostatic measurement

measurement where the incident and reflected waves follow the same direction and which lie at an arbitrary angle with respect to normal to the specimen surface

3.1.19

normal incidence

the incidence for which an electromagnetic wave strikes to the specimen surface normally

The reflectivity in normal incidence is usually measured in the configuration where the incident angle of a transmitting antenna and that of a receiving antenna are within 0° to 5° with respect to the normal direction of the specimen surface.

3.1.20

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oblique incidence https://standards.iteh.ai/catalog/standards/sist/0b07e76f-406a-45c5-bbbathe incidence for which an electromagnetics wave strikes to the specimen surface at an oblique angle

The reflectivity in oblique incidence is usually measured with a transmitting and receiving antenna set up so that the incident and reflected angle of EM wave may be equal.

3.1.21

parallel beam

EM wave, which has a nearly flat phase front on the surface normal to the antenna axis, and which is formed using a dielectric lens set-up in front of a horn antenna

3.1.22

reference metal plate

metal plate with the same shape and an equal surface projected area in normal to the specimen

3.1.23

reflectivity

the ratio between reflected EM wave voltage received by the receiving antenna when a specimen is irradiated by the EM wave, and the voltage of the EM wave reflected from a metal plate with equal size and with the same projection shape in normal to the specimen surface expressed in decibel by

reflectivity =
$$20 \log_{10} \left| \frac{V_{\rm S}}{V_{\rm m}} \right| = 20 \log_{10} \left| V_{\rm S} \right| - 20 \log_{10} \left| V_{\rm m} \right| \, [dB]$$
(1)

where V_s is the reflected EM wave voltage received by the receiving antenna when a specimen is irradiated by the EM wave, and V_m is the voltage of the EM wave reflected from a

metal plate with equal size and with the same projection shape in normal to the specimen surface. See Figure 1.



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Key

- 1 Tx antenna
- 2 Rx antenna
- 3 EMA
- 4 Metal plate

iTeh STANDARD PREVIEW (standards.iteh.ai) Figure 1 – Definition of reflectivity

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a function that is implemented in VNA to transform the measured frequency domain data to time evolution data using inverse Fourier transform because the VNA can measure both the amplitude and phase of EM wave

Using this function, the reflected wave only from the specimen can be extracted by applying a suitable time gating to the time evolution output signal and Fourier transform.

3.1.25 transverse electric wave

TE wave

EM wave in which the electric field is perpendicular to the plane of incidence when the EM wave is incident to the specimen surface at an oblique angle

3.1.26

transverse electromagnetic wave

TEM wave

EM wave in which both the electric and magnetic fields are perpendicular to the direction of incidence when an EM wave is incident normally to the specimen surface

3.1.27 transverse magnetic wave

TM wave

EM wave in which the magnetic field is perpendicular to the plane of incidence when the EM wave is incident to the specimen surface at an oblique angle

3.2 Acronyms and symbols

The acronyms and symbols are shown in Table 1 and Table 2.

Acronyms	
CW	Continuous wave
EMA	Electromagnetic wave absorber
FFT	Fast Fourier transformation
IF	Intermediate frequency
NWA	Network analyzer
PTFE	Polytetrafruorethylene
SNA	Scalar network analyzer
TE	Transverse electric
TEM	Transverse electromagnetic
ТМ	Transverse magnetic
TRL	Thru-reflect-line
VNA	Vector network analyzer
VSWR	Voltage standing wave ratio

Table 1 – Acronyms

Table 2 – Symbols

Symbol	iTeh STANDARD Meaning VIEW
А	A half size of the aperture of an ideal absorber wall (a half side of metal plate with squared shape (Amex A) aros. iten.ai)
а	Longer side size at aperture of pyramidal horn antenna
b	Shorter side size at the aperture of a pyramidal horn antenna
C	Length of pyramidal horn antenna 12008
C(<i>x</i>)	Fresnel integral
D	Diameter of the aperture of a conical horn antenna
<i>d</i> ₁	Distance from mirror image of transmit antenna to the aperture of ideal absorber wall
d ₂	Distance from the aperture of an ideal absorber wall to receiving antenna
D _m	Effective maximum dimension of the antenna aperture
E ₀	Electric field strength at the position of an ideal absorber (Annex A)
E _r	Receiving electric field strength in the case that an ideal absorber has a square- shaped aperture with size 2a (Annex A)
E _{s0}	Receiving electric field strength in the case that ideal absorber is not put (Annex A)
G _d	Directional gain of horn antenna
R	Distance from the aperture of horn antenna to the specimen
R _a	Receiving level in the case that the test specimen is put on the specimen holder (dB)
R _m	Receiving level in the case that the reference metal plate is put on the specimen holder (dB)
S ₁₁	Reflection coefficient
S ₂₁	Transmission coefficient
S(x)	Fresnel integral
V _a	Receiving voltage in the case that the test specimen is put on the specimen holder
V _d	Receiving voltage by direct wave from the transmitting and receiving antenna
V _m	Receiving voltage by the reflected wave from the metal plate with the same cross section and shape as the test specimen
V _r	Receiving voltage by the reflected wave except for the test specimen

Symbol	Meaning
V _s	Receiving voltage by the reflected wave only from the test specimen
β	Phase constant $(=2\pi/\lambda)$
Γ _a	Receiving level in the case that the electromagnetic absorber is put on the specimen holder (vector quantity)
Γ_{m}	Receiving level in the case that the reference metal plate is put on the specimen holder (vector quantity)
Γ _r	Receiving level in the case that the test specimen is not put on the specimen holder (vector quantity)
٤r'	Real part of relative permittivity
θ	Incident angle of electromagnetic wave
λ	Wavelength of electromagnetic wave in free-space

Table 2 (continued)

4 Specimen

4.1 Specimen specification

It is recommended that the specimen have a flat surface and rigid structure having a dimension equal to or larger than $10 \lambda_{\rm lr}$, where $\lambda_{\rm h}$ is the wavelength of the EM wave at the lowest frequency in the measurement frequency range. However, detailed specifications are given in each type of the three measurement methods described in Clauses 9, 10, and 11.

4.2 Reference metal plate

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4.2.1 Material and thickness s.iteh.ai/catalog/standards/sist/0b07e76f-406a-45c5-bbba-

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Aluminium, copper, stainless steel or other metal, which has thickness of about 1 mm to 2 mm, is preferred.

4.2.2 Surface roughness

The surface roughness of a reference metal plate should be less than $\lambda_m/10$, although less than $\lambda_m/20$ is preferred, where λ_m is the wavelength that corresponds to maximum frequency in the measurement frequencies range. For example, if the maximum frequency is 300 GHz, then λ is 1 mm, and the preferable roughness becomes 0,05 mm.

4.2.3 Flatness

It is recommended that the flatness be less than 0,5 mm for a reference metal plate with size $1 \text{ m} \times 1 \text{ m}$.

4.2.4 Size and shape

The reference metal plate should have the same size and same projection shape normal to the specimen surface. However, it is desirable to use the size specified by each method in Clauses 9, 10, and 11. Care should be taken in selecting the size of the reference metal plate because the reflection and scattering characteristics may depend on its size due to the Fresnel refraction. The dependence of the reflection and scattering characteristics on the size in the case of the horn antenna method is illustrated in Annex A.

4.3 Reference specimen for calibration

The reference specimen for calibration should be silica-glass plate or sapphire single crystal (001) plate with uniform thickness and smooth surface roughness. Relative permittivity should

be known in advance. When dielectric material is selected, it is necessary to measure the reflectivity of the specimen without putting anything on the backward surface of the reference specimen. The reference specimen should be fixed by a material such as foamed plastics, which has relative permittivity near to 1, and in which EM waves do not reflect like they do in free space. It is recommended to verify the accuracy of the measurement system by comparing the measured reflectivity with the theoretical one. The reflectivity of a silica-glass plate measured in the millimetre wave range is given in Annex B.

5 Specimen holder

A specimen holder might be different by the any type of measurement method mentioned in Clauses 9, 10, and 11. It should be recommended that the specimen holder possess functions for adjusting azimuth and elevation.

6 Measurement equipment

The equipment must be calibrated according to the procedure established by the manufacturers, or calibration laboratories accredited by ISO/IEC 17025. The items to be calibrated include frequency, voltage, and attenuation, which depend on the measurement accuracy or uncertainty of the measurement apparatuses. Correct usage of the measurement equipment is very important in order to obtain the exact results. The measurement of the reflectivity of EMA shall be performed using either a VNA or SNA. When there are discrepancies in the measured results, it is necessary to make calibration of the measurement system using a reference specimen. Various necessary apparatuses should be selected according to the type of used measurement methods as shown below.

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6.1 Type of network analyzer

IEC 62431:2008

The VNA is recommended because it can/measure both the magnitude and phase of S_{11} and S_{21} and it has a time domain function 306a9b32affiec-62431-2008

The SNA can measure only the magnitude of S_{11} and S_{21} .

6.2 Antenna

6.2.1 Horn antenna

Both a commercial as well as an in-built horn antenna can be used for the reflectivity measurement of EMA except in special cases. However, the commercial horn antenna is recommended in order to obtain the required measurement accuracy, which has an accurate gain, VSWR, and size. The commercial coaxial-waveguide transducer is also recommended where the VSWR or sizes are verified in each frequency band. The specifications of some commercial horn antennas are shown in Annex C.

6.2.2 Lens antenna

Not only a dielectric lens antenna but also a metal plate lens antenna or Luneberg lens antenna can also be used for the reflectivity measurement of EMA in this standard. Either a commercially available or an in-built product can also be applicable. However, the use of a commercial lens antenna, in which antenna gain, VSWR, and sizes are specified, will be recommended in order to realize the required measurement accuracy. The specifications of commercial horn antennas and dielectric lenses are illustrated in Annex C.

6.3 Amplifier

An amplifier is generally used in order to get a sufficient dynamic range for the measurement system. The warming up of the amplifier is required and the temperature should be kept as